



應用科學研究中心

Research Center for Applied Sciences



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Applications of Ultrafast Photoemission Electron Microscopy in Plasmonics

Date: 2019.09.23 (Mon.)

Time: 14:00-15:00

**Venue: B106 Auditorium, 1F, IRBST,
Academia Sinica**

跨領域科技研究大樓 1F B106 演講廳

Host: Prof. Shangjr (Felix) Gwo 果尚志主任